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				Application Number	
				Filing Date	
				First Named Inventor	
				Group Art Unit	
Examiner Name		Attorney Docket Number			
Sheet	1	of	1	09/986,743	
				November 9, 2001	
				Shunpei YAMAZAKI et al.	
				2812	
				Alexander Ghyka	
				0756-2378	

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
AC		2002/0031876		Hara et al.	03/14/2002	
		4,343,829		Tochikubo et al.	08/10/1982	
		5,436,920		Minemoto et al.	07/25/1995	
		5,589,233		Law et al.	12/31/1996	
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FOREIGN PATENT DOCUMENTS								
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
AC		Specification, Claims, Abstract and Drawings of U.S. Patent Application Serial No. 10/871,380 filed June 21, 2004 entitled <i>Laser Apparatus, Laser Annealing Method, and Manufacturing Method of a Semiconductor Device</i>	
AC		Official Action dated October 20, 2004 in U.S. Application Serial No. 10/871,380	

Examiner Signature	<i>AC Ghyka</i>	Date Considered	1/17/05
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